



IPW

PATENT
29936/39481

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Ihl Hyun Cho

I hereby certify that the documents referred to as enclosed therewith are being deposited with the United States Postal Service on as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, Virginia 22313-1450, on August 17, 2004,

Serial No.: 10/618,292

Filed: July 11, 2003

For: Method of Manufacturing Semiconductor Devices

Group Art Unit: 2812

Examiner: Krystyna Susecksi


Michael R. Hull

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Commissioner:

In response to the Office Action mailed on May 18, 2004, please amend the above-identified patent application as follows.

Amendments to the specification begin on page 2 of this paper.

Remarks in support of an allowance of this application begin on page 3 of this paper.